

<b>Notice of References Cited</b>		Application/Control No. 10/747,888	Applicant(s)/Patent Under Reexamination JEONG, CHI WEON	
		Examiner Leonard R. Leo	Art Unit 3753	Page 1 of 1

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**NON-PATENT DOCUMENTS**

Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)

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